

From: [REDACTED]@semi.org]

Sent: Tuesday, April 12, 2016 2:59 PM

To: [REDACTED] (GROW); [REDACTED] (ENV); [REDACTED] (GROW); [REDACTED] (GROW); [REDACTED] (ENV)

Cc: [REDACTED]

Subject: SEMI & ESIA joint comments - PFOA restriction - derogation for semiconductor manufacturing equipment

Dear [REDACTED] Dear All,

In follow up to the stakeholder workshop of 15 March and as already indicated by my mail dated 30 March, please find attached additional comments jointly submitted by SEMI and ESIA regarding the derogation for semiconductor manufacturing equipment.

We and remain at your disposal should you require any additional clarifications.

Thank you in advance for your consideration.

Kind Regards,

[REDACTED]

[REDACTED]

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